

Supporting Information

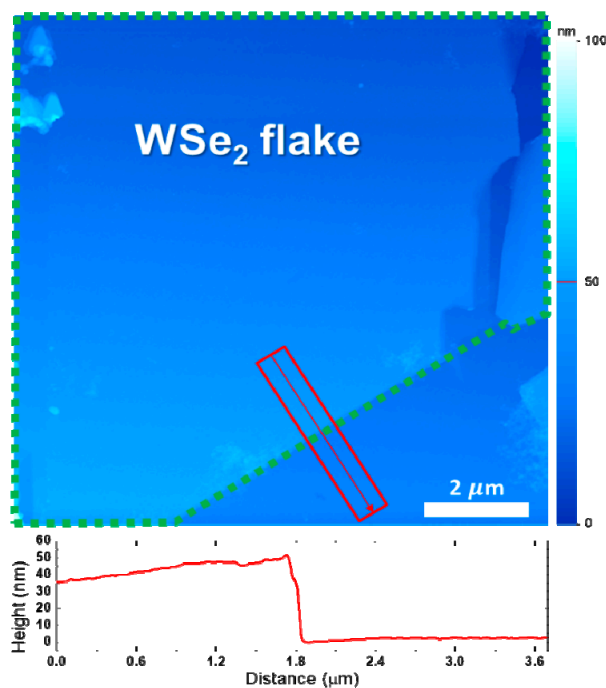
# Interfacial Doping Effects in Fluoropolymer-Tungsten Diselenide Composites Providing High-Performance P-type Transistors

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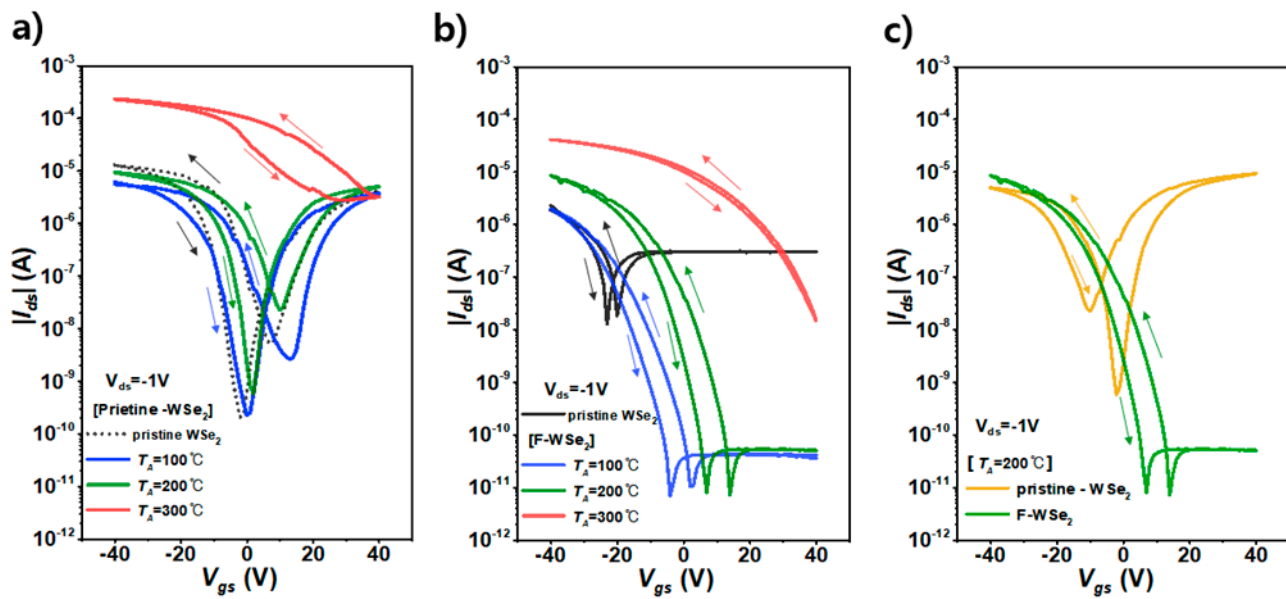
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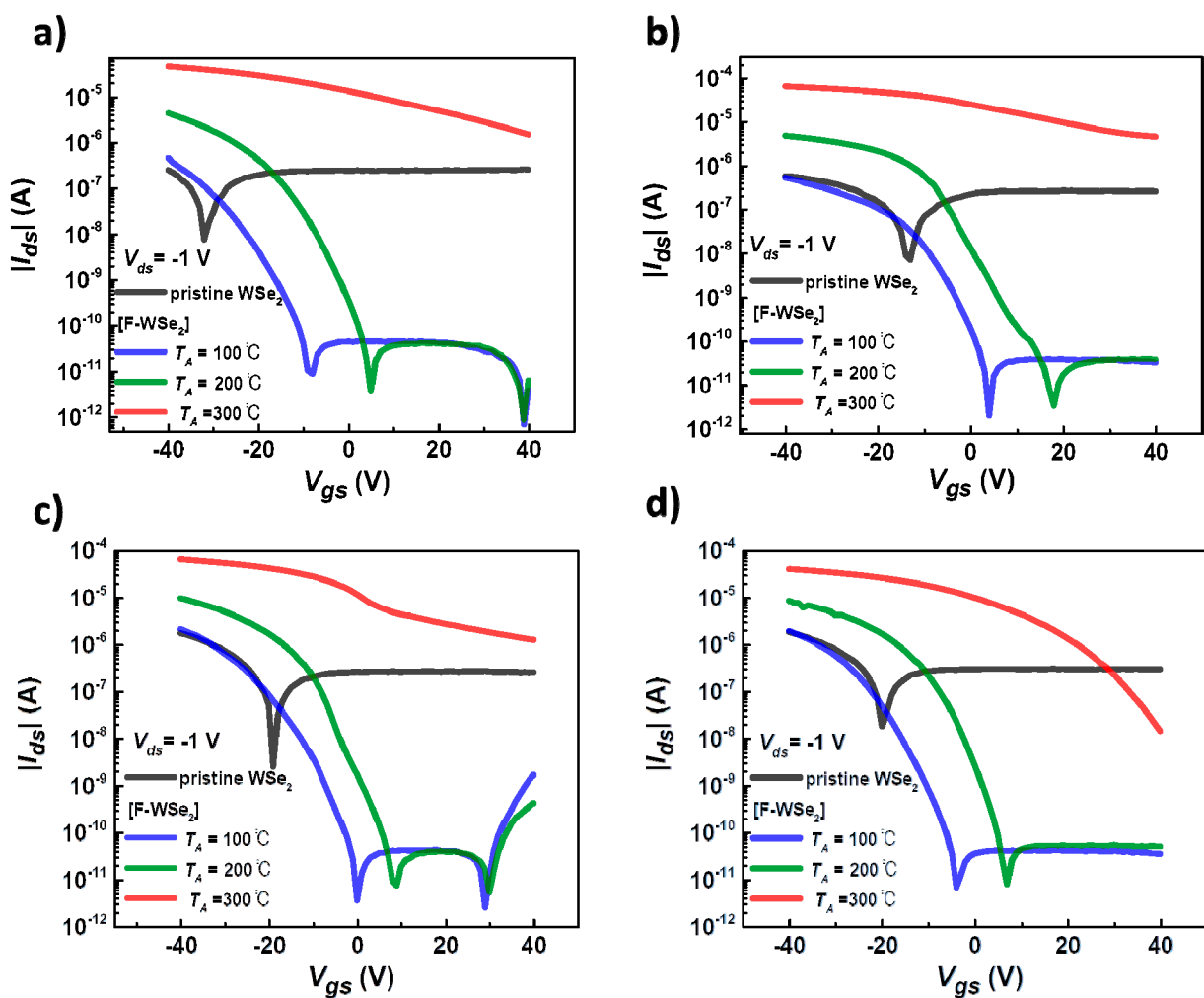
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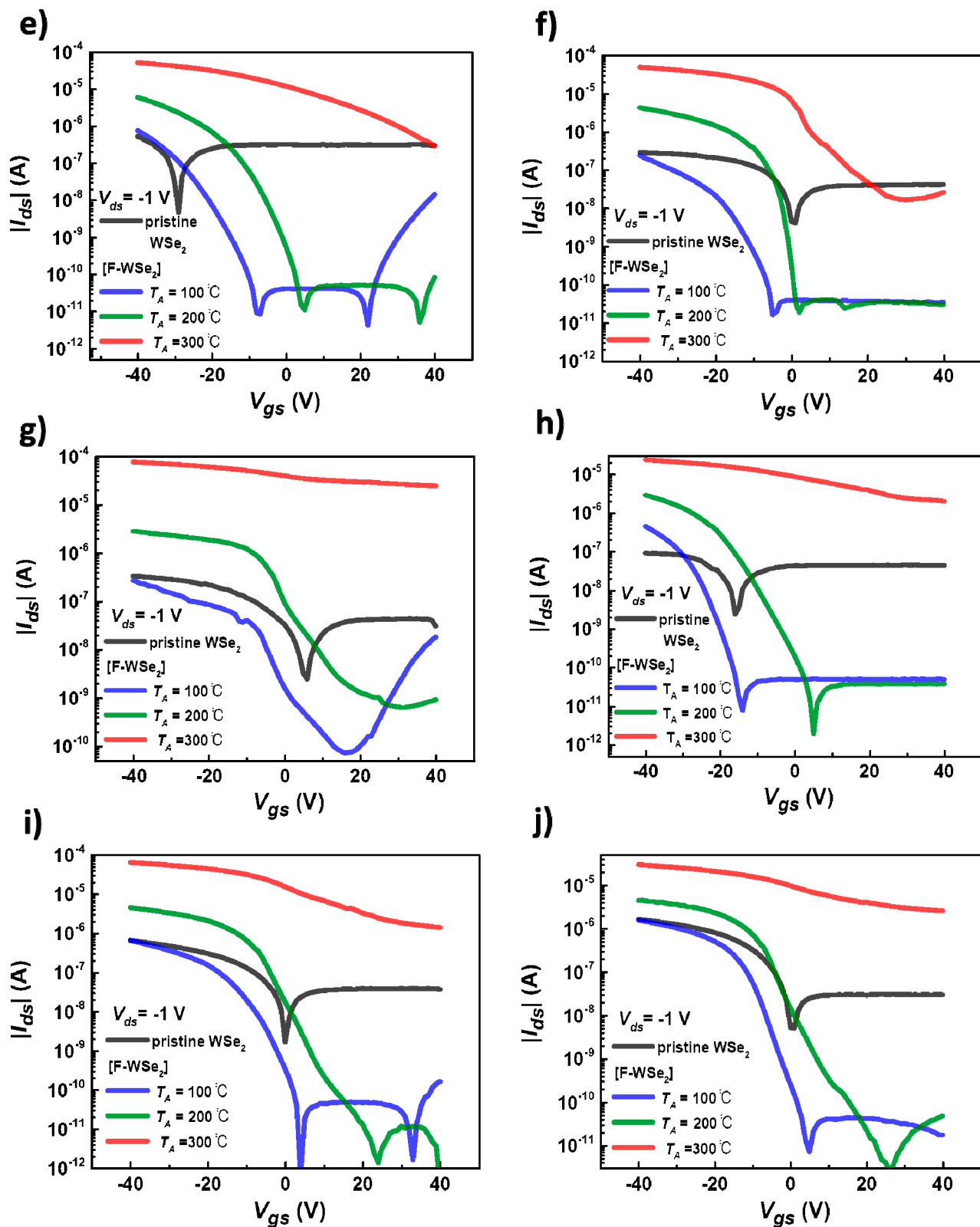


**Figure S1.** AFM image of F-WSe<sub>2</sub> device flake and its thickness profile.



**Figure S2.** Transfer curves at  $V_{ds} = -1$  V of (a) the pristine  $WSe_2$  device ( $T_A = 100, 200, 300$  °C), (b) the F- $WSe_2$  device ( $T_A = 100, 200, 300$  °C), (c) comparing transfer curves between the pristine  $WSe_2$  and the F- $WSe_2$  at the same annealing condition  $T_A = 200$  °C





**Figure S3.** (i)-(j) are transfer curves ( $I_{ds}$ - $V_{gs}$ ) for 10 pristine  $WSe_2$  and F- $WSe_2$  devices used in the histogram. After measuring the transfer curves of the pristine  $WSe_2$  devices, the F- $WSe_2$  devices coated with Cytop on the devices were annealed at  $T_A = 100, 200$  or  $300$  °C for 30 min to measure the transfer curve again. Using this investigation, the tendency of the electrical characteristic changes on the Cytop doping effect was investigated.

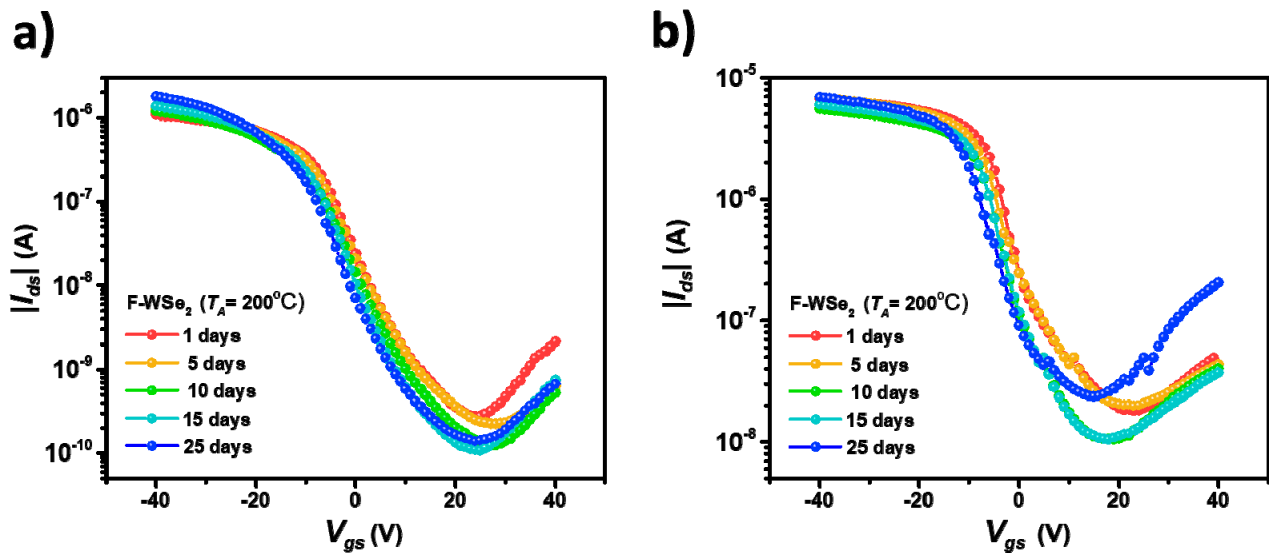


Figure S4. (a), (b) Transfer curves for 25 days in air in two F-WSe<sub>2</sub> ( $T_A = 200\text{ }^\circ\text{C}$ ) devices. It shows that in air, the electrical properties can be maintained over time.

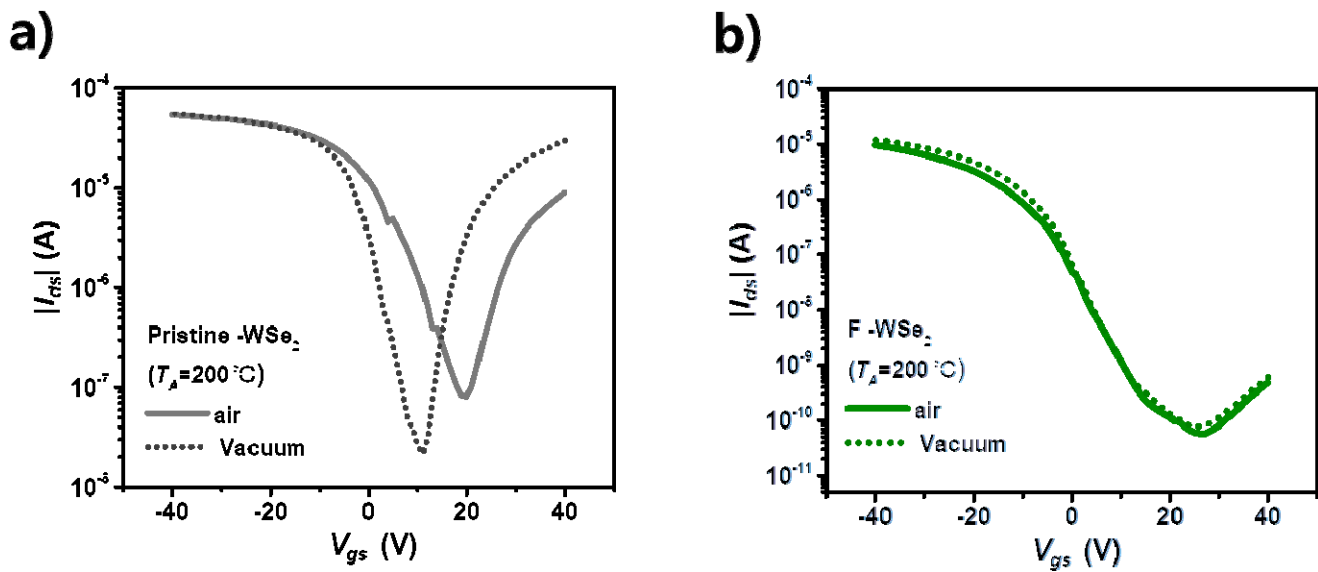
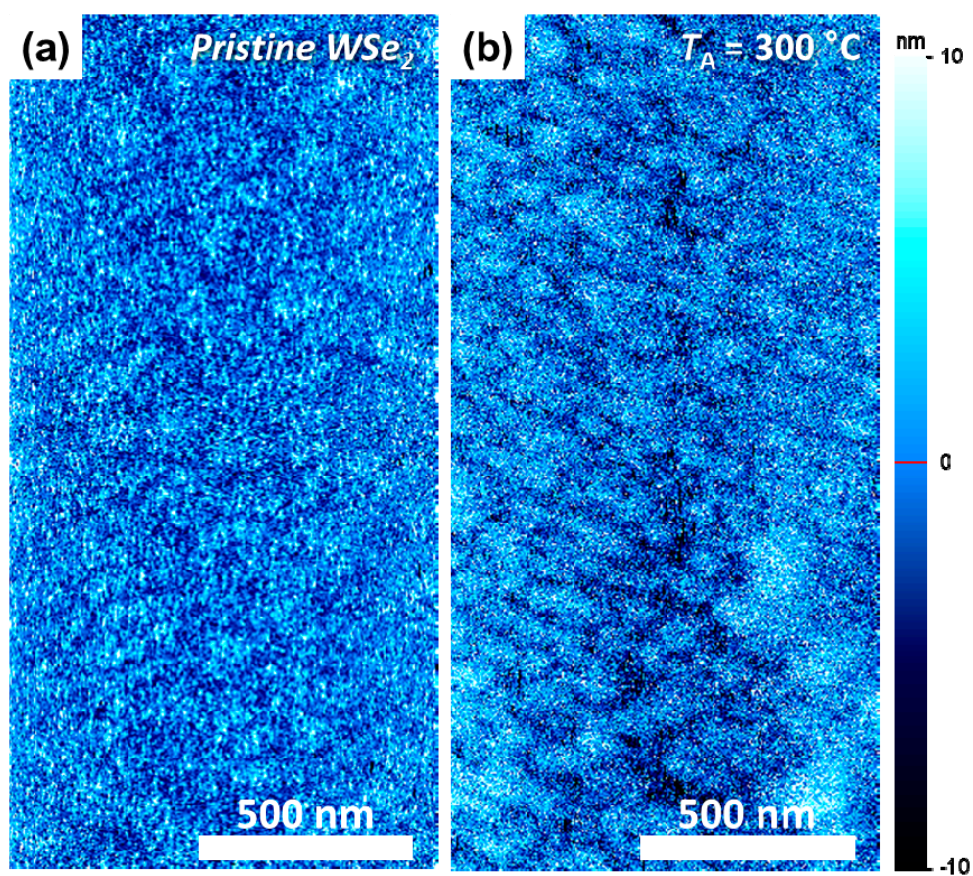
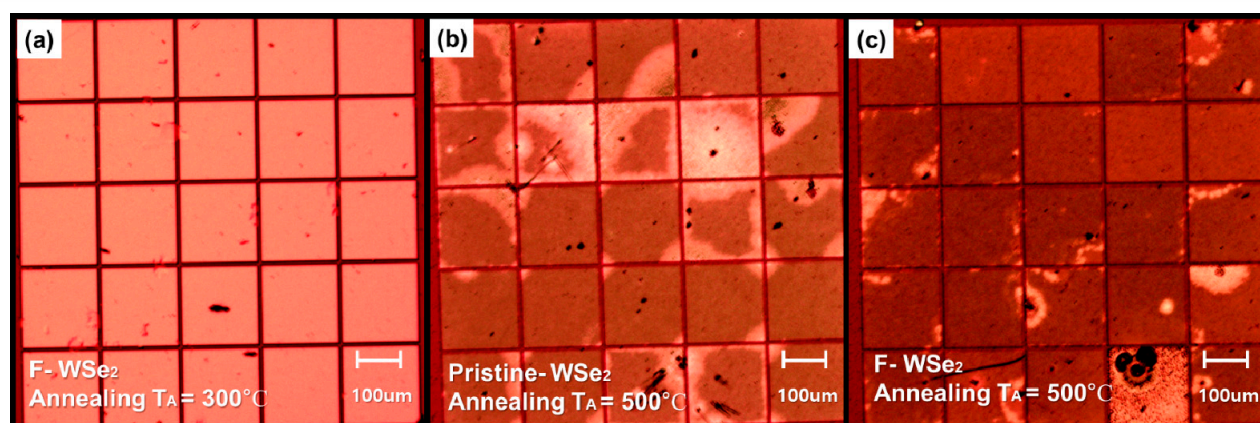


Figure S5. (a) Transfer characteristics of pristine WSe<sub>2</sub> ( $T_A=200\text{ }^\circ\text{C}$ ) in air and vacuum (b) Transfer characteristics of F-WSe<sub>2</sub> ( $T_A=200\text{ }^\circ\text{C}$ ) in air and vacuum



**Figure S6.** Surface morphology of (a) pristine WSe<sub>2</sub> film and (b) WSe<sub>2</sub> annealed at 300 °C for 30 min. The scale bar is 500 nm.



**Figure S7.** Optical microscope images of (a) F-WSe<sub>2</sub> (T<sub>A</sub>=300°C), (b) pristine WSe<sub>2</sub> (T<sub>A</sub>=500°C), (c) F-WSe<sub>2</sub> (T<sub>A</sub>=500°C), respectively.

Device	Contact metal	Current on/off ratio ( $I_{on}/I_{off}$ )	Maximum Hole mobility ( $\text{cm}^2 \text{V}^{-1} \text{s}^{-1}$ )	Bias stress	Air stability	Hysteresis	Ref.
<b>F-Wae<sub>2</sub></b> ( $T_A=200^\circ\text{C}$ )	Ti/ Au	$10^6$	85	O	25 days	O	This Work
<b>WSe<sub>2</sub> - PFS</b>	Au	$10^5$	28	N/A	14 days	N/A	[S1]
<b>WSe<sub>2</sub>-Ozone</b>	Cr/Au	$10^6$	41.4	N/A	N/A	N/A	[S2]
<b>WSe<sub>2</sub>- Oxygen plasma</b>	Cr/Au	$10^6$	71	N/A	90 days	N/A	[S3]
<b>BN- WSe<sub>2</sub></b>	Ti/Pb	$10^7$	83	N/A	N/A	N/A	[S4]
<b>WSe<sub>2</sub> - UV/ozone</b>	Ti/Pt	$10^8$	72.9	N/A	N/A	N/A	[S5]
<b>WSe<sub>2</sub>- O<sub>3</sub></b>	Ti/Au	$10^7$	31	N/A	24h	O	[S6]

**Table S1** | Comparison of electrical characteristics of high-performance WSe<sub>2</sub> devices.

TMDs	Dopant	Raman peak shift (cm <sup>-1</sup> )		Ref.
		A <sub>g</sub>	E <sub>g</sub>	
WSe <sub>2</sub>	T <sub>A</sub> =100°C	0.004	0.003	This work
	Cytop T <sub>A</sub> =200°C	0.64	0.13	
	T <sub>A</sub> =300°C	1.26	1.25	
ReSe <sub>2</sub>	HCl	0.24	0.14	[S7]
WSe <sub>2</sub>	HCl	0.25	0.25	[S8]
WSe <sub>2</sub>	OTS	/	0.372	[S9]
MoS <sub>2</sub>	APTES	0.8	0.9	[S10]
MoS <sub>2</sub>	N <sub>2</sub> plasma	0.43	/	[S11]
MoS <sub>2</sub>	PPh <sub>3</sub>	0.78	0.78	[S12]
WSe <sub>2</sub>	PPh <sub>3</sub>	1.13	0.34	[S13]

**Table S2** | Raman shift comparison for TMD doping.

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